

CPA/1765  
JF



35.C12395 CIP

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
YOSHIHIKO FUKUMOTO  
Application No.: 09/429,530  
Filed: October 28, 1999  
For: METHOD FOR FABRICATING  
SEMICONDUCTOR DEVICE

Examiner: V. Perez Ramos  
Group Art Unit: 1765

August 28, 2001

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Melia  
8/30/01

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Commissioner for Patents  
Washington, D.C. 20231

PETITION UNDER 37 C.F.R. § 1.136(a)

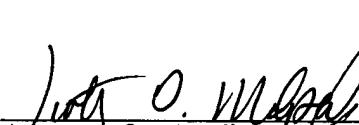
Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated February 28, 2001, for three months from May 28, 2001, to August 28, 2001.

Submitted herewith is a check for \$890.00 to cover the fee for the extension under 37 C.F.R. § 1.17. Any deficiency in or overpayment of this fee should be charged or credited to Deposit Account No. 06-1205. A duplicate copy of this petition is enclosed.

Applicant's undersigned attorney may be reached in our Washington DC office by telephone at (202) 530-1010. All correspondence should continue to be directed to our New York office at the address given below.

Respectfully submitted,

  
\_\_\_\_\_  
John O. Walsh  
Attorney for Applicant

Registration No. 32,533

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